

Mass Flow Controller for SEMI or Vacuum

Easy upgrade for more stable control response, adjustable to under 50 ms





Upgrading Is Easy!

Preconfigured instruments feature welded 1/4" male VCR fittings and analog 0-5v and digital RS-485 communications via DB-15 connector. Full-scale ranges available from 0-10 sccm to 0-20 slpm.

MCE Series



Replacement for MKS 1179A, GE50A and other similar mass flow controllers.

Also available with welded 1/4" male compression fittings.

MCV Series for vacuum apps



Includes integrated pneumatic shutoff valve. Replacement for MKS 2179A, GV50A and similar flow controllers.

See the video!



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Mass Flow Controllers (SEMI / Vacuum)

Hit the mark every time! Control flows with rock-solid stability and responsiveness.

Making You Faster

- 50-100 ms (or lower) control response: stills upstream fluctuations.
- Accessible PID valve tuning for best speed and stability.
- Control mass flow, vol. flow or pressure with one device.
- No warm-up: ready to control process flows in one second.

Quick Specs

- Accuracy: 0.8% of the reading (0.4% optional) + 0.2% full-scale repeatability (NIST-traceable).
- Linear range: 0.5-100% of full scale (200:1).
- Multi-gas calibration: 98-130 gases preloaded, plus COMPOSER™ gas composition firmware.
- All flow data visible on one screen (setpoint, mass flow, vol. flow, pressure, temperature).
- Lifetime warranty gives you peace of mind.

Tailored for You

Common Options:

- Matching pinouts for any manufacturer's 9-pin and 15-pin D-Sub connectors.
- **Digital communications** via RS-232 or RS-485.
- Analog signals: 0-10v, 0-5v, 1-5v or 4-20 mA.
- Welded fittings in VCR or compression formats.
- Precision Dispensing Package relies on our fast valves to dispense metered amounts of gas.
- Industrial communications: EtherNet/ IP, DeviceNet, PROFIBUS, or Modbus
- Anti-Corrosive Configuration
 Features 316L stainless steel flow
 path and sensor to better withstand
 corrosion caused by aggressive gases.
 All ranges.

Sample Application

Gas Flow Control for Reactive Sputtering

